



MICRON.080C1C

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Deboer et al.  
Appl. No. : 10/714,688  
Filed : November 17, 2003  
For : METHOD AND STRUCTURE  
FOR REDUCING CONTACT  
ASPECT RATIOS  
Examiner : Bradley Smith  
Group Art Unit : 2824

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

Sept. 28, 2004

(Date)

Adeel S. Akhtar

Adeel S. Akhtar, Reg. No. 41,392

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed June 29, 2004, please amend the above-identified application as set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.